



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 17, 2026

IGI Report Number

LG811672308

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

10.21 - 10.27 X 6.32 MM

GRADING RESULTS

Carat Weight

4.09 CARATS

Color Grade

F

Clarity Grade

VVS 2

Cut Grade

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

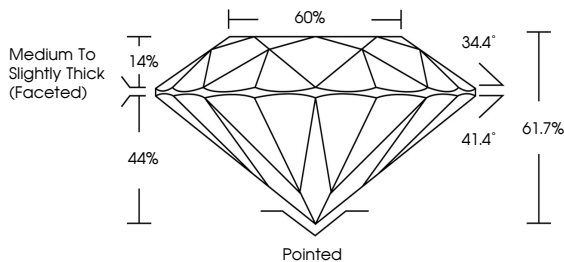
NONE

Inscription(s)

 LG811672308

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

34.4°

41.4°

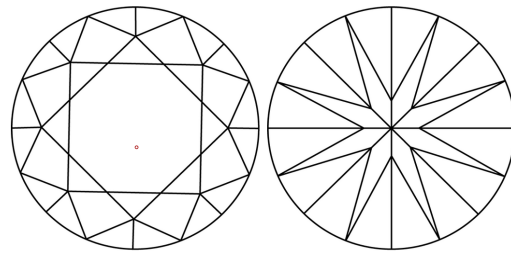
61.7%

44%

14%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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4.09 CARATS

F

Color Grade

VVS 2

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IDEAL

Depth

61.7%

Table

65%

Girdle

Medium To Slightly Thick (Faceted)

Culet

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Polish

EXCELLENT

Symmetry

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Fluorescence

NONE

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